Substitute	Substitute for form 1449A/PTO		Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			LOSURE	Application Number	09/295,607
				Filing Date	April 22, 1999
				First Named Inventor	Shunpei YAMAZAKI
			iry)	Art Unit	2811
				Examiner Name	Shouxiang Hu
Sheet	1	of	1	Attorney Docket Number	740756-1961

U.S. PATENT DOCUMENTS						
Examiner Initials <sup>*</sup>	Cite No. <sup>1</sup>	U.S. Patent Document  Number - Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document  Kind Code <sup>5</sup> Country Code <sup>3</sup> Number <sup>4</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	$\mathrm{T}^6$
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Examiner Initials* Cite Include name of the author (in CAPITAL LETTERS), title of the article (when item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), publisher, city and/or country where published.			atalog, etc.)., date, page(s), volume		$T^2$	
		Gerova, "Deposition of AlN Thin Films by Magnetron Reactive Sputtering", Thin Solid Films – Preparation and Characterization, Vol. 81, (1981), pp. 201-206.				

Examiner	Date	
Signature	Considered	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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